

ABSTRACT

A multi-layer piezoelectric element includes a stacked body in which piezoelectric layers and internal electrode layers are alternately laminated and a stress relaxing layer is disposed at part of portions between the piezoelectric layers, and an external electrode that is bonded to a side face of the stacked body so as to make electrical connection with the internal electrode layers, the internal electrode layers being not exposed on the side face of the stacked body, but the stress relaxing layer being exposed on the side face of the stacked body.